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Applicant's Docket No. 740789-54350

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Michael Stephen Boger et al.

Application No.:	10/644,274	Group No.:	2823
Filed:	August 20, 2003	Examiner:	GARCIA, Joannie A.
Confirmation No.:	5179		
For:	CONTROL OF ETCH AND DEPOSITION PROCESSES		

MAIL STOP AMENDMENT
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

In response to the Office Communication Action dated December 28, 2004, applicants submitted a Supplemental Restriction Requirement, on January 26, 2005. The Notice of Non-Compliant Amendment mailed April 18, 2005 (copy enclosed) indicated that the amendment was improper because in claim 20, line 1, deletion of "a" before "semiconductor" and insertion instead of --s-- was not properly indicated. Accordingly, applicants are submitting herewith a corrected Claim Listing.

Amendments to the claims are reflected in the corrected listing of claims which begins on page 2 of this paper. Remarks begin on page 5 of this paper.